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Substitute for form 1449/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  <i>(Use as many sheets as necessary)</i>				<b>Complete if Known</b>	
				Application Number	10/756,122-Conf. #4554
				Filing Date	January 13, 2004
				First Named Inventor	Wai-Fan Yau
				Art Unit	2823
				Examiner Name	J. J. Maldonado
Sheet	1	of	2	Attorney Docket Number	002592.C7/DSM/LOW K/JW

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
/J.M./	A1*	US-6,150,252	11-21-2000	Hsu et al.	/
	A2*	US-5,942,802	08-24-1999	Aoi	
	A3*	US-5,827,785	10-27-1998	Bhan et al.	
	A4*	US-5,753,564	05-19-1998	Fukada	
	A5*	US-5,693,928	12-02-1997	Egitto et al.	
	A6*	US-5,552,344	09-03-1996	Jang et al.	
	A7*	US-5,510,105	04-23-1996	Strom	
	A8*	US-4,717,585	01-05-1988	Ishihara et al.	
	A9*	US-4,599,243	07-08-1986	Sachdev et al.	
/J.M./	A10*	US-20050051900	03-10-2005	Liu et al.	

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)				

Examiner Signature	/Julio Maldonado/	Date Considered	07/21/2009
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Sheet	2	of	2	Attorney Docket Number	002592.C7/DSM/LOW K/JW

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
/J.M./	C1	K.H.A. BOGART, ET AL., "Plasma Enhanced Chemical Vapor Deposition of SiO <sub>2</sub> Using Novel Alkoxysilane Precursors," J. Vac. Sci. Technol. A, Vol. 13, No. 2, Mar/Apr 1995, pages 475-480.	
	C2	A. KLUMP, "Photo Induced Transformation of Polysiloxane Layers to SiO <sub>2</sub> ," Applied Surface Science, Volume 43 (1989), pages 301-303.	
	C3	The Board's Decision on Appeal mailed September 16, 2004, for Serial No. 09/477,126, filed December 30, 1999 (AMAT/2592.X1).	
	C4	The Board's Decision on Request for Rehearing mailed December 23, 2004, for Serial No. 09/477,126, filed December 30, 1999 (AMAT/2592.X1).	
	C5	WOLF, et al.; Silicon Processing for the VLSI Era, Volume 1; Process Technology, 1986 by Lattice Press, pp. 161-174.	
/J.M./	C6	Prosecution History for U.S. Patent Application No. 11/877,483 filed October 23, 2007 (APPM/002592.C12)	

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